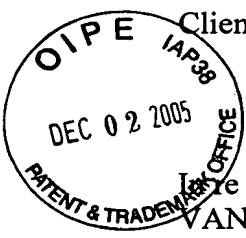


Attorney Docket: 081468-0305146
Client Reference: P-1585.000-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:
VAN DER NET et al.

Confirmation Number: 4722

Application No.: 10/623,180

Group Art Unit: 2851

Filed: July 21, 2003

Examiner: Fuller, Rodney Evan

Title: LITHOGRAPHIC PROJECTION APPARATUS, GAS PURGING METHOD AND DEVICE MANUFACTURING METHOD AND PURGE GAS SUPPLY SYSTEM

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated June 6, 2005, the period for reply being extended by the Petition for Three-Months Extension of Time filed herewith, please amend the above-identified application as follows:

Addendum

Invention Title:

LITHOGRAPHIC PROJECTION APPARATUS, GAS PURGING METHOD AND
DEVICE MANUFACTURING METHOD AND PURGE GAS SUPPLY SYSTEM